



GAU 2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Hisashi OHTANI et al.)
Serial No. 09/593,765) Art Unit: 2812
Filed: June 14, 2000) Examiner:
For: METHOD FOR MANUFACTURING)
A SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

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LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:


The Examiner's attention is respectfully directed to the Information Disclosure Statement filed June 14, 2000 in which a Japanese patent document, 03-22540 dated January 30, 1991 was submitted. Subsequently, the full English translation of same was filed on July 21, 2000. Copies of the relevant documents are attached for the Examiner's convenience.

It has come to Applicant's attention that the full translation of this document contains an apparent typographical error on page 2, line 13, and on page 4, line 4, insofar as the reference to "120°" should read "1200°". While it appears that this referenced measure is correctly described on page 4, line 25, as well as in the Abstract originally submitted on June 14, 2000, consideration of this correction is respectfully requested.

It is therefore respectfully requested that, upon consideration and return of the aforementioned PTO Form 1449, the Examiner acknowledge the correction in the full translation.

The Commissioner is hereby authorized to charge any deficiencies in fees, or to credit any overpayment, to counsel's Deposit Account No. 19-2380.

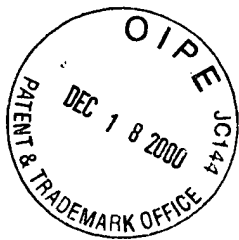
Respectfully submitted,


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Docket No. 0756-2149

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Hisashi OHTANI et al.) Art Unit: Unassigned
Serial No. 09/593,765) Examiner: Unassigned
Filed: 06/14/2000)
For: METHOD FOR MANUFACTURING)
A SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

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INFORMATION DISCLOSURE STATEMENT
REQUEST FOR CORRECTION

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

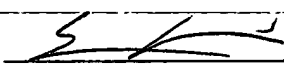
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

An Information Disclosure Statement was filed on June 14, 2000, that incorrectly listed the Japanese Patent Laid -Open No. 3-22540 as 3-25540. Further an Information Disclosure Statement was submitted on July 21, 2000, including a Full Translation of the 3-22540 patent, and a 1449 correctly listing 3-22540. Therefore, we request that the 3-25540 in the original 1449 filed July 14, 2000 be deleted or crossed out by the examiner form the 1449.

Furthermore, article (see Hazelden et al.) submitted on June 14, 2000, includes an incorrect date. Specifically, the date is listed as 1991 when it should be 1992. We request that the examiner correct this date on the 1449 when reviewing the Information Disclosure Statement.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,


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